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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Inventors: Akira NAKANO, et al.

Application No.: 10/574,858

Filed: April 6, 2006

For: HERMETIC COMPRESSOR AND MANUFACTURING METHOD
OF SUCTION MUFFLER

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents
Washington, DC 20231

Dear Sir:

Pursuant to Rules 56 and 99, Applicants hereby call the attention of the Patent Office to the documents listed on the attached Form PTO 1449. JP '064 and JP '739 are cited on page 2 of the Specification.

Applicants present this art so that the Patent Office may, in the first instance, determine any relevancy thereof to the presently claimed invention, see Beckman Instruments, Inc. v. Chemtronics, Inc., 439 F.2d 1369, 1380, 165 USPQ 355, 364 (5th Cir. 1970). Also see Patent Office Rules 104 and 106. Applicants respectfully request that this art be expressly considered during the prosecution of this application and made of record herein and

appear among the "References Cited" on any patent to issue herefrom.

Respectfully submitted,



James E. Ledbetter
Registration No. 28,732

Date: January 29, 2007

JEL/jpf

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<p>FORM PTO-1449 U.S. Department of Commerce (Rev. 4/92) Patent and Trademark Office</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(Use several sheets if necessary)</p> <p>O P E N I M A P S</p> <p>JAN 29 2007</p>	ATTY. DOCKET NO.	SERIAL NO.
	L8638.06106	10/574,858
	APPLICANT	Akira NAKANO, et al.
	FILING DATE	GROUP
April 6, 2006	3748	

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.